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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/627,554	07/25/2003	Florian Patrick Nierhaus	2003P04477US	3548
7590	09/07/2010		EXAMINER	
Attn: Elsa Keller, Legal Administrator Siemens Corporation Intellectual Property Department 170 Wood Avenue South Iselin, NJ 08830			LE, KAREN L	
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Please find below and/or attached an Office communication concerning this application or proceeding.

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ATTN: ELSA KELLER, LEGAL ADMINISTRATOR
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Appeal No: 2010-011575
Application: 10/627,554
Appellant: Florian Patrick Nierhaus et al.

**Board of Patent Appeals and Interferences
Docketing Notice**

Application 10/627,554 was received from the Technology Center at the Board on August 31, 2010 and has been assigned Appeal No: 2010-011575.

In all future communications regarding this appeal, please include both the application number and the appeal number.

The mailing address for the Board is:

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The facsimile number of the Board is 571-273-0052. Because of the heightened security in the Washington D.C. area, facsimile communications are recommended. Telephone inquiries can be made by calling 571-272-9797 and referencing the appeal number listed above.

By order of the Board of Patent Appeals and Interferences.